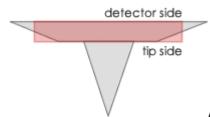
Cantilever Data	Value	Range*
Resonance Frequency	13 kHz	9 - 17 kHz
Force Constant	0.2 N/m	0.07 - 0.4 N/m
Length	450 µm	445 - 455 μm
Mean Width	50 µm	45 - 55 μm
Thickness	2 µm	1.5 - 2.5 μm

NanoWorld® Pointprobe® CONT probes are designed for contact mode imaging. Furthermore this AFM probe can be used for forcedistance spectroscopy mode or pulsed force mode (PFM). The CONT type is optimised for high sensitivity due to a low force constant.

All SPM and AFM probes of the Pointprobe® series are made from monolithic silicon which is highly doped to dissipate static charge. They are chemically inert and offer a high mechanical Q-factor for high sensitivity. The AFM tip is shaped like a polygon based pyramid with a typical height of 10 - 15  $\mu$ m.

The AFM tip radius of curvature is less than 25 nm.



A trapezoidal cross section of the

AFM cantilever and therefore 30% wider (e.g. NCH) AFM cantilever detector side result in easier and faster laser adjustment. Additionally, because there is simply more space to place and reflect the laser beam, a higher SUM signal is reached.

Tip shape: Standard

Coating: Electrically Conductive

## PtIr5 Coating

The PtIr5 coating consists of a 23 nm thick platinum iridium5 layer deposited on both sides of the AFM cantilever. The tip side coating enhances the conductivity of the AFM tip and

allows electrical contacts. The detector side coating enhances the reflectance of the laser beam by a factor of 2 and prevents light from interfering within the AFM cantilever.

The coating process is optimized for stress compensation and wear resistance. Wear at the AFM tip can occur if operating in contact-, friction- or force modulation mode. As the coating is almost stress-free the bending of the AFM cantilever due to stress is less than 2 degrees.

Order Code	Quantity	Data Sheet
CONTPt-10	10	yes
CONTPt-20	20	yes
CONTPt-50	50	no
CONTPt-W	380	yes